## Notice of References Cited Application/Control No. | Applicant(s)/Patent Under Reexamination | PAPA RAO ET AL. | Examiner | Art Unit | Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,074,945	06-2000	Vaartstra et al.	438/681
	В	US-2004/0028882	02-2004	Andricacos et al.	428/209
	С	US-2002/0185671	12-2002	Kim, Si Bum	257/301
	۵	US-6,518,668	02-2003	Cohen, Uri	257/751
	Е	US-			
	F	US-			
	G	US-			
	н	US-			
	ı	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	s					
	Т					

## NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U	Stanley Wolf, Silicon Processing for the VLSI ERA,1986, Vol. 1, pages 335-353			
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	w				
	×				

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.